

Our scanning electron microscope solutions

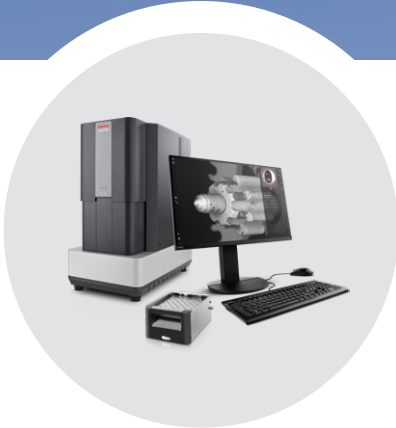
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Instruments



Phenom Pure, Pro(X) G6 Desktop SEMs



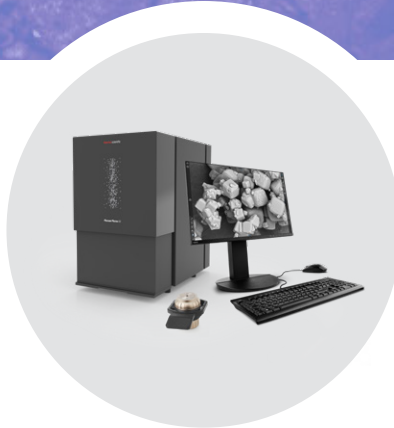
Phenom XL G2 Desktop SEM



Axia ChemiSEM System



Prisma E SEM



Phenom Pharos G2 Desktop SEM



Quattro ESEM



Apreo ChemiSEM System



Verios 5 XHR SEM

Source type

Cerium hexaboride (CeB₆)

Tungsten (W)

Schottky field emission (FEG)

Maximum resolution



Sample size



Detector type

Secondary electrons (SE)

Backscattered electrons (BSE)

Low-vacuum SE

Cathodoluminescence

Low-vacuum BSE

STEM

WetSTEM

Gaseous SED

Environmental capabilities

High vacuum

Low vacuum

Environmental

Analytical capabilities

Elemental analysis

Particle analysis

Microstructural analysis

Correlative microscopy

Scripting

Fiber analysis

Image interpretation

 Optional

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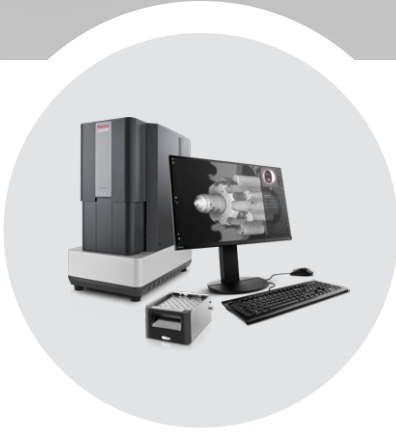
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Instruments



Phenom Pure, Pro(X) G6 Desktop SEMs



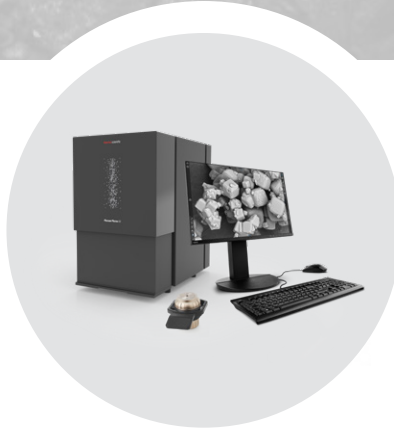
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Quattro ESEM



Apreo ChemiSEM System



Verios 5 XHR SEM

Source type

Cerium hexaboride (CeB₆)

Tungsten (W)

Schottky field emission (FEG)

Maximum resolution

6 nm

Sample size

25 mm

Detector type

Secondary electrons (SE)
⌘

Backscattered electrons (BSE)

Low-vacuum SE

Cathodoluminescence

Low-vacuum BSE

STEM

WetSTEM

Gaseous SED

Environmental capabilities

High vacuum

Low vacuum

Environmental

Analytical capabilities

Elemental analysis
⌘

Particle analysis
⌘

Microstructural analysis

Correlative microscopy
⌘

Scripting
⌘

Fiber analysis
⌘

Image interpretation
⌘

⌘ Optional

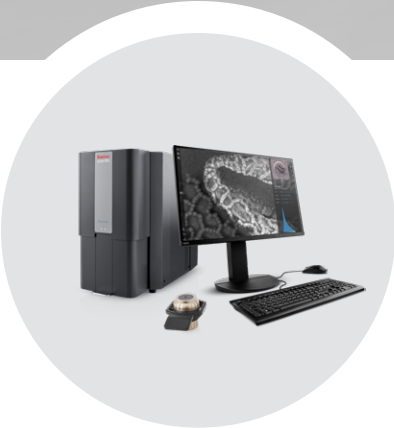
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Instruments



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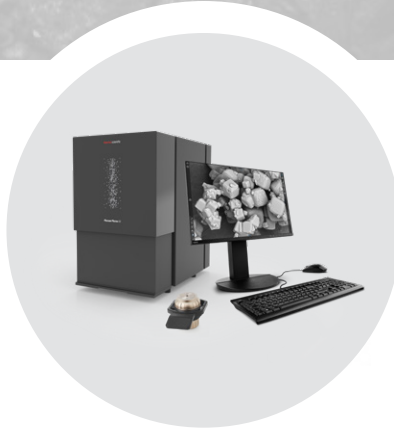
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Verios 5 XHR SEM

Source type

Cerium hexaboride (CeB₆)

Tungsten (W)

Schottky field emission (FEG)

Maximum resolution

10 nm

Sample size

100 mm

Detector type

Secondary electrons (SE)
*

Backscattered electrons (BSE)

Low-vacuum SE

Cathodoluminescence

Low-vacuum BSE

STEM

WetSTEM

Gaseous SED

Environmental capabilities

High vacuum

Low vacuum

Environmental

Analytical capabilities

Elemental analysis
*

Particle analysis
*

Microstructural analysis

Correlative microscopy
*

Scripting
*

Fiber analysis
*

Image interpretation
*

* Optional

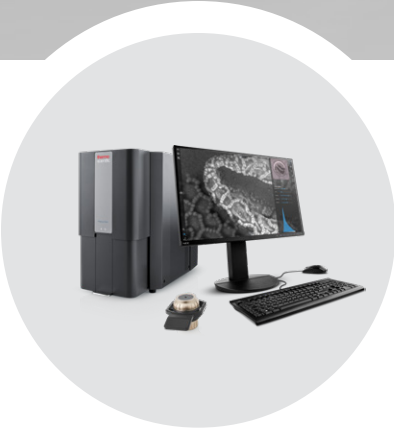
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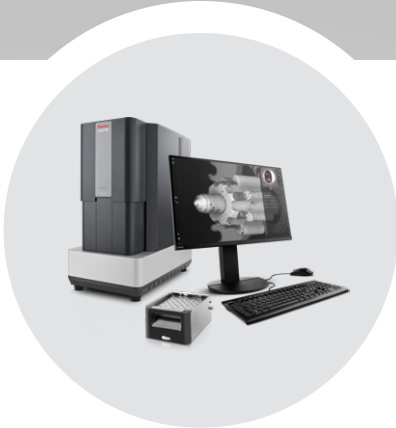
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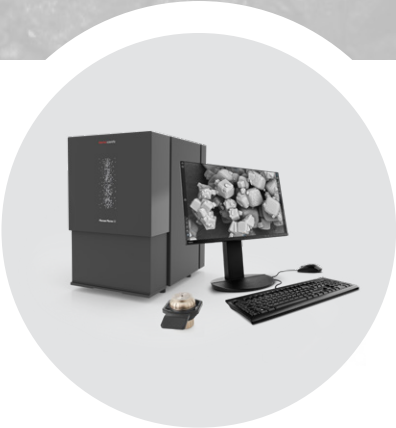
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Source type

Cerium hexaboride (CeB₆)

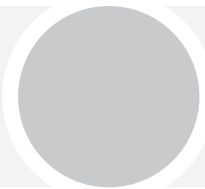
Tungsten (W)

Schottky field emission (FEG)

Maximum resolution



Sample size



Detector type

Secondary electrons (SE)

Backscattered electrons (BSE)

Low-vacuum SE

Cathodoluminescence

Low-vacuum BSE

STEM

WetSTEM

Gaseous SED

Environmental capabilities

High vacuum

Low vacuum (10-150 Pa)

Environmental

Analytical capabilities

Elemental analysis

Particle analysis

Microstructural analysis

Correlative microscopy

Scripting

Fiber analysis

Image interpretation

⌘ Optional

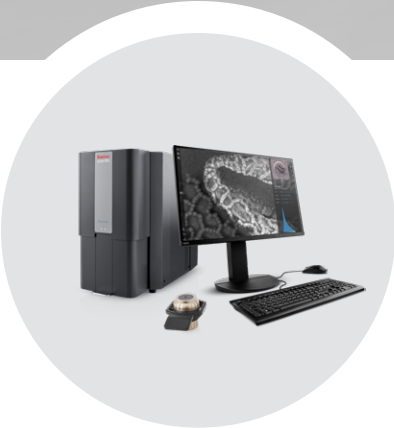
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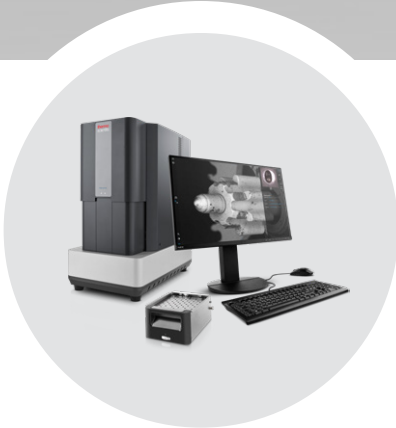
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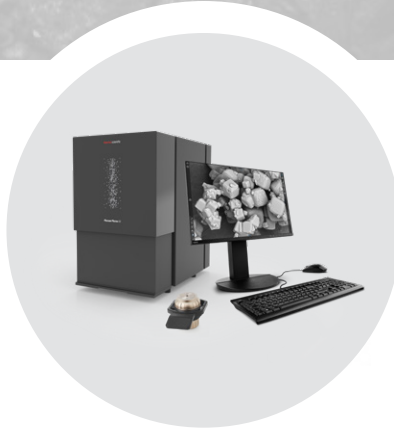
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Verios 5 XHR SEM

Source type

Cerium hexaboride (CeB₆)

Tungsten (W)

Schottky field emission (FEG)

Maximum resolution



Sample size



Detector type

Secondary electrons (SE)

Backscattered electrons (BSE)

Low-vacuum SE

Cathodoluminescence

Low-vacuum BSE

STEM

WetSTEM

Gaseous SED

Environmental capabilities

High vacuum

Low vacuum (10-130 Pa)

Environmental (130-2600 Pa)

Analytical capabilities

Elemental analysis

Particle analysis

Microstructural analysis

Correlative microscopy

Scripting

Fiber analysis

Image interpretation

* Optional

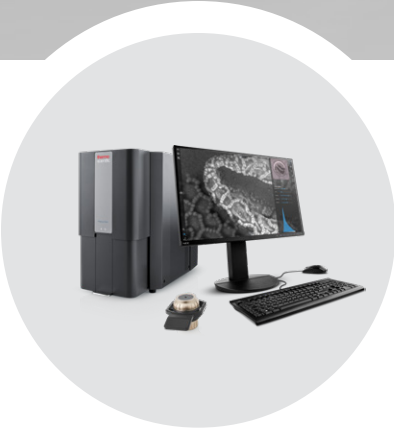
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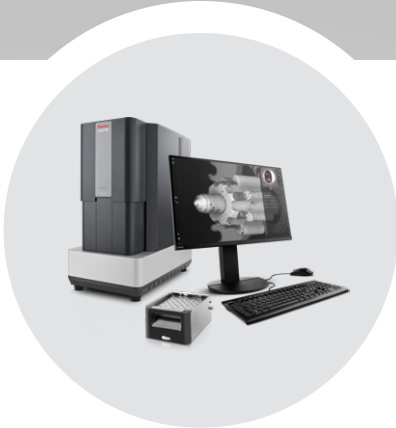
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Source type

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Tungsten (W)

Schottky field emission (FEG)

Maximum resolution



Sample size



Detector type

Secondary electrons (SE) *

Backscattered electrons (BSE)

Low-vacuum SE

Cathodoluminescence

Low-vacuum BSE

STEM *

WetSTEM

Gaseous SED

Environmental capabilities

High vacuum

Low vacuum

Environmental

Analytical capabilities

Elemental analysis *

Particle analysis *

Microstructural analysis

Correlative microscopy *

Scripting *

Fiber analysis *

Image interpretation *

* Optional

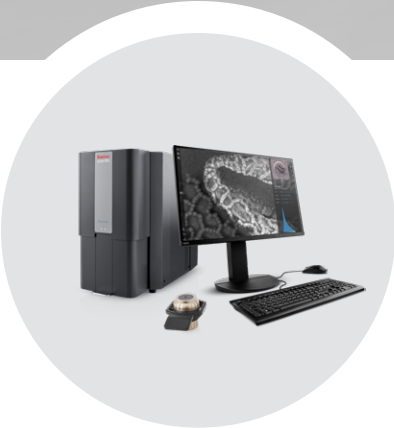
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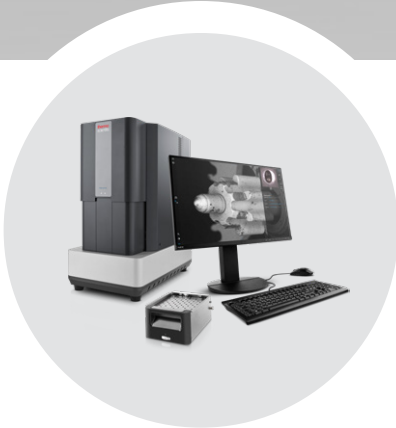
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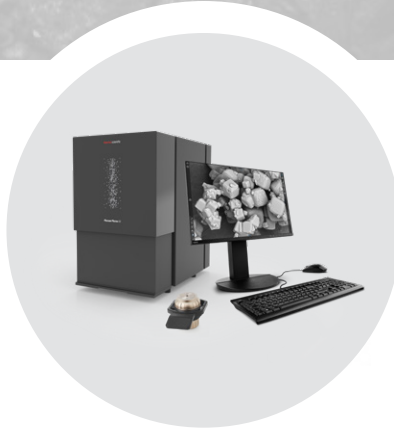
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Verios 5 XHR SEM

Source type

Cerium hexaboride (CeB₆)

Tungsten (W)

Schottky field emission (FEG)

Maximum resolution

0.8 nm

Sample size

122 mm

Detector type

Secondary electrons (SE)

Backscattered electrons (BSE)

Low-vacuum SE

Cathodoluminescence

Low-vacuum BSE

STEM

WetSTEM

Gaseous SED

Environmental capabilities

High vacuum

Low vacuum (10-200 Pa)

Environmental (200-4000 Pa)

Analytical capabilities

Elemental analysis

Particle analysis

Microstructural analysis

Correlative microscopy

Scripting

Fiber analysis

Image interpretation

⌘ Optional

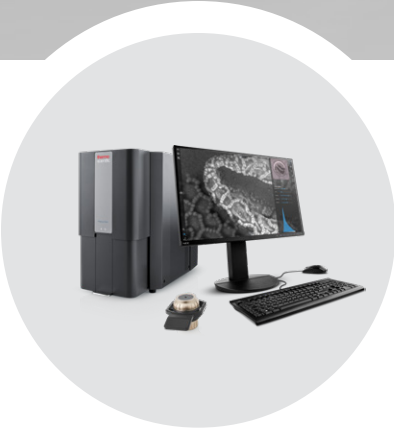
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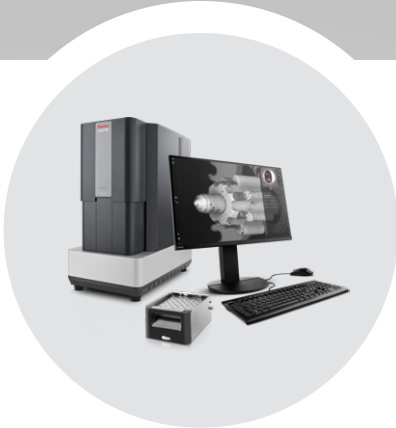
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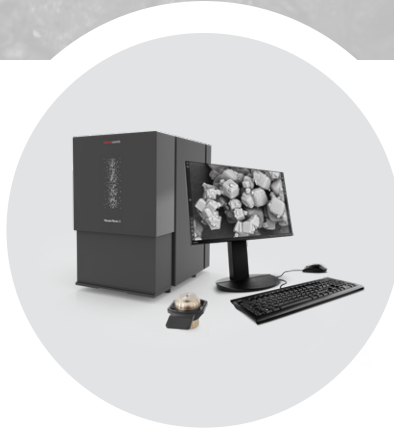
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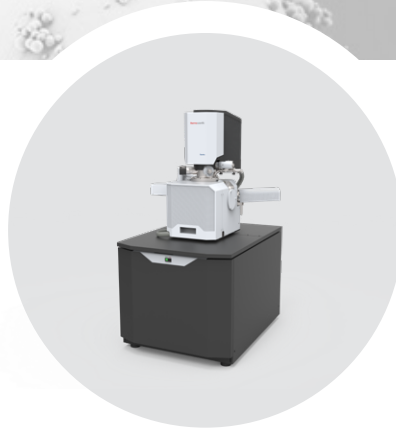
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Prisma E SEM



Phenom Pharos G2 Desktop SEM



Quattro ESEM



Apreo ChemiSEM System



Verios 5 XHR SEM

Source type

Cerium hexaboride (CeB₆)

Tungsten (W)

Schottky field emission (FEG)

Maximum resolution

0.7 nm

Sample size

122 mm

Detector type

Secondary electrons (SE)

Backscattered electrons (BSE)

Low-vacuum SE

Cathodoluminescence

Low-vacuum BSE

STEM

WetSTEM

Gaseous SED

Environmental capabilities

High vacuum

Low vacuum (10-500 Pa)

Environmental

Analytical capabilities

Elemental analysis

Particle analysis

Microstructural analysis

Correlative microscopy

Scripting

Fiber analysis

Image interpretation

⌘ Optional

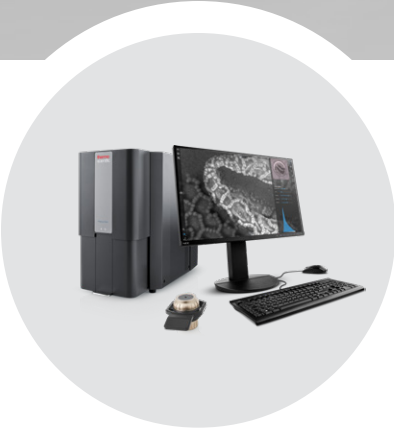
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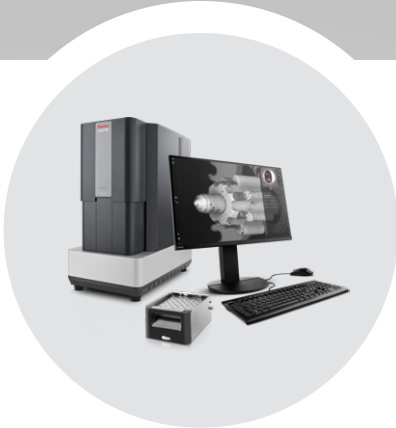
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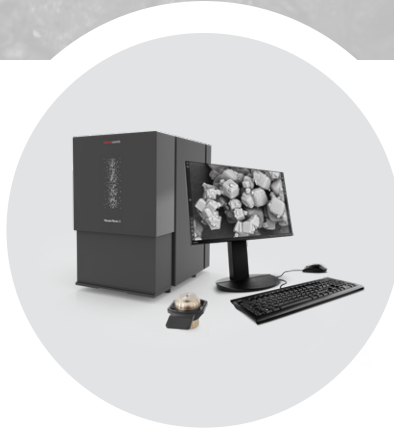
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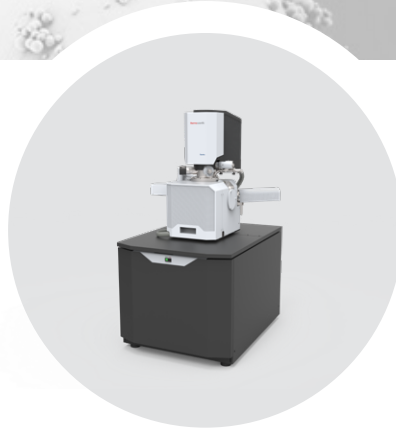
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Verios 5 XHR SEM

Source type

Cerium hexaboride (CeB₆)

Tungsten (W)

Schottky field emission (FEG)

Maximum resolution

0.6 nm

Sample size

100 mm

Detector type

Secondary electrons (SE)

Backscattered electrons (BSE)

Low-vacuum SE

Cathodoluminescence

Low-vacuum BSE

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Environmental capabilities

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Low vacuum

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⌘ Optional

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